Inventor:

Vladimir S gal et al.

Title:

Methods of Forming Aluminum-Comprising Physical Vapor

**Sputtered** Films: Deposition Targets; and Target

Constructions

Assignee:

Honeywell International Inc.

Serial No.: Filed herewith

Filing Dt.:

Filed herewith

Honeywell Docket No.: 30-5022(4015)

## INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 2//3/0/

Attornev:

David G. Latwesen, Ph.D.

Reg. No. 38,533

Wells, St. John, Roberts,

Gregory & Matkin, P.S.